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Attorney Docket # 5300-17

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Neil S CASA

Serial No.: 10/007,618

Filed: November 07, 2001

For: System And Method For Inhibiting Motion Of  
Semiconductor Wafers In A Variable-Pressure  
Chamber

Examiner:  
Group Art:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

November 8, 2002

(Date of Deposit)

Thomas Langer

Name of applicant/assignee or Registered Representative

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Signature

November 8, 2002

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Assistant Commissioner for Patents  
Washington, D.C. 20231

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Please also change the attorney docket number from to 5300-17. Thank you.

Respectfully submitted,  
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Dated: November 8, 2002